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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

	Complete if Know	n Oll Etc
Application Number	10/624,593	3
Filing Date	July 23, 2003	JAN 1 0 2005
First Named Inventor	Kei HAYASAKI	\2 \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \
Art Unit	- <del>1752</del> 173(,	(F) 10°
Examiner Name	<del>Unknown</del>	MADENAM
Attomey Docket Number	r 04329.3100	

		U.S. PATENTS	AND PUBLISHED	U.S. PATENT APPLICAT	IONS	
Examiner	Cite	Document Number	Issue or	Name of Patentee or	Pages, Columns, Lines, Where	
Initials	No. <sup>1</sup>	Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear	
		US-		· .		
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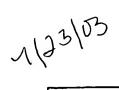
Note: Copies of the U.S. Patent Documents are not Required in IDS filed after October 21, 2004

	FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>		
ng		JP 1-189123	07/28/1989	Japan		No		
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	NON PATENT LITERATURE DOCUMENTS						
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation <sup>6</sup>				
		Notification of First Office Action issued by Chinese Patent Office in Chinese application No. 031503136, and English translation of Notification	Yes				

Examiner Signature	rich	Bonn	Date Considered	9/20105
				1 1-3

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



## **INFORMATION DISCLOSURE CITATION**

Atty. Docket No.	04329.3100	Serial No.	Not Yet Assigned	10/624593
Applicants	KeiHAYASAKI et al.			
Filing Date	July 23, 2003	Group:	Not Yet Assigned	1734

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Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
NY	6,372,413 B2	04/16/02	EMA et al.	<130	324	
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	Document · Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
nn	2001-085407	03/30/01	JAPAN			ABSTRACT
ny	2002-023390	01/23/02	JAPAN	-		ABSTRACT
why	2001-110711	04/20/01	JAPAN			ABSTRACT
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*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					
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